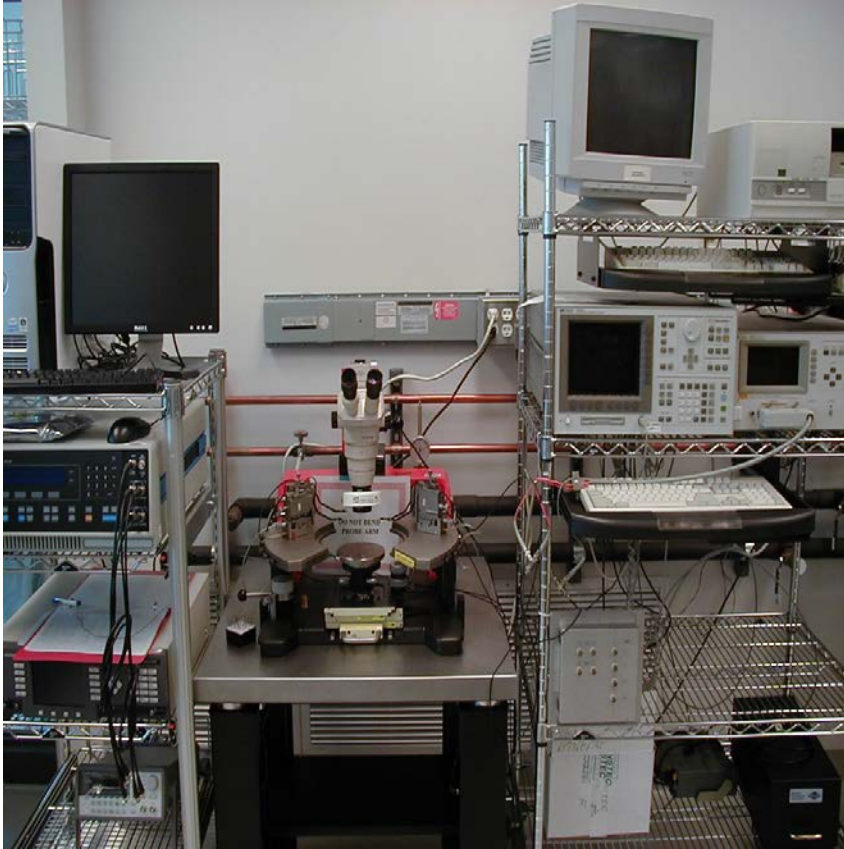


Analyzer Probe Station



- The Karl Suss probe station that includes a HP semiconductor parameter analyzer and HP LCR meter is located in the Class-1000 cleanroom.
- This is a fully automatic, high performance instrument designed to measure IV & CV, display graphically, and analyze the dc parameters and characteristics of semiconductor devices such as diodes, transistors, IC's solar cells, and wafers during and after the fabrication process.